Substitute for form 14	49A/PTO	C mplete if Kn wn				
		Application Number				
INFORMAT	ION DISCLOSURE	Filing Date				
STATEMEN	IT BY APPLICANT	First Named Inventor	Ishikawa, Tetsuya			
		Art Unit	Not yet assigned			
(use as m	any sheets as necessary)	Examiner Name	Not yet assigned			
Sheet 1	of	Attorney Docket Number	A4356/T35310			
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Examiner Initials*	Cite No.	Number Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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Examiner Initials*	Cite No.1	For	eign Patent Document  Number <sup>4</sup> Kind Code <sup>6</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Unes, Where Relevant Passages or Relevant Figures Appear	το
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	AW						
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	BB					T	

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Examiner Signature	My	1 La	Date Considered	7/19/04	

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Substitute for form 1449B/PTO	Complete if Known			
	Application Number			
INFORMATION DISCLOSURE	Filing Date			
STATEMENT BY APPLICANT	First Named Inventor	Ishikawa, Tetsuya		
	Art Unit	Not yet assigned		
(use as many sheets as necessary)	Examiner Name	Not yet assigned		
Sheet 2 of	Attorney Docket Number	A4356/T35310		

	NON PATENT LITERATURE DOCUMENTS					
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²			
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